



**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2851
PATENT**

Customer No. 22,852
Attorney Docket No. 04329.2348

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Iwao HIGASHIKAWA) Group Art Unit: 2851
Application No.: 09/615,605) Examiner: Cruz, Magda
Filed: July 13, 2000)
For: PATTERN FORMING METHOD) **Mail Stop AF**
AND LIGHT EXPOSURE)
APPARATUS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed September 16, 2003, the period for response having been extended to February 17, 2004 (February 16th being a Federal Holiday) by a Petition for Extension of Time for two (2) months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper, beginning on page 2.

Remarks/Arguments follow the amendment section of this paper, beginning on page 7.